

Conductors:

characterized by loosely bound electrons that can easily move throughout the material, allowing current flow; e.g. copper, silver, aluminium

Insulators:

tightly bound electrons that resist movement, resulting in a poor conductor, e.g. rubber, glass

Semiconductors:

bridge the gap btwn. conductors & insulators. their conductivity can be controlled

Importance:

allow precise contrall of currents. helps build electronic comp. such as:

Transistors:

fundamental building block of modern electronics, acting as switches & amplifiers

Integrated Circuits (ICs):

combine multiple transistors & other comp. on a single chip - cores of microprocessors

Light-emitting diodes (LEDs):

convert electrical energy into light, used in displays & lighting application

Silicon

Advantages:

- Abundant (2nd) & Earth-friendly
- Building Blocks & Protection
 - acts as protection to shield delicate comp. as on insul.
- Tailoring Conductivity
 - controlled via doping: introduce specific impurities

Types of Semiconductor

Intrinsic Semiconductors: The Natural State

- pure semiconducting mat. (single atom species)
- e.g. Si & Ge (Germanium)
- show intrinsic electrical props. w/o intentional impurities
- natural state: a specific energy band structure allowing moderate conductivity

Extrinsic Semiconductors: Doping Adds New Possibilities

- intentionally modified by introducing impurity atoms via doping, which can alter mat.'s electrical props.
- 2 common types:

p-type semiconductors:

doped w/ elements that create **holes** in the valence band → (+) charge carriers

n-type semiconductors

doped w/ elements that introduce **extra electrons** → (-) charge carriers

Silicon Wafer:

single-crystal slices of silicon w/ precise thickness & orientation & are substrates for microelectronics

- microchips, solar cells, transistors, & diodes
- recyclable & energy efficient

Silicon Ingot Production

The Czochralski Method:

creates a solid, single-crystal structure from molten Si

Process:

1. A seed crystal (small Si crystal) dipped into a molten silicon melt & is slowly pulled out while rotating
2. Silicon atoms attach to the ascending seed & grow as a single crystal

Advantages: high-yield, cost-effective, large-scale

Wafer Slicing & Polishing

Ingots are cut into thin wafers using diamond saws & polished to achieve uniform thickness & flatness

Wafer Cleaning & Inspection

Chemical Cleaning Methods:

Wafers are immersed in chemical solutions (e.g. acids, bases, or solvents) that effectively remove organic & inorganic contaminants

Mechanical Cleaning Methods:

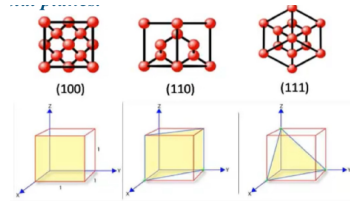
Ultrasonic cleaning exposes wafers to high frequency soundwaves that dislodge contaminants

Quality Control

automated optical & laser-based systems detect defects, scratches, or irregularities; metrology tools are used to measure thickness & surface roughness to ensure reproducibility.

Crystal Structure of Silicon Wafers

Si atoms are arranged in a diamond cubic lattice; each atom bonds w/ 4 neighboring atoms.



Anisotropy:

different crystallographic planes have varying properties

Dopant Diffusion:

dopants (e.g. boron, phosphorus) diffuse diff. along crystal axes

Etching Selectivity:

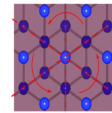
etchants preferentially attack specific crystal planes

- Crystal orientation affects electrical behav. (impact electrical props.)
- Carrier mobility: electrons & holes move faster along certain crystal directions
- Threshold Voltage: varies based on orientation
- Transistor Performance: Anisotropy influences transistor characteristics

Orientation

<1, 0, 0> Orientation:

- AKA "wafer flat" orientation
- The surface aligns w/ Si lattice
 - (atoms lie in square grid)
- Commonly used for CMOS (Complementary Metal-Oxide-Semiconductor)
- Anisotropic props. allow provision of better transistor perform. control



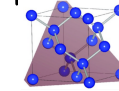
How <1, 0, 0> break:

"cleavage planes" are lines of weakness along which the crystal can easily fracture; 1 set of these planes is parallel to the wafer surface
→ mortar joints btwn bricks



<1, 1, 1> Orientation:

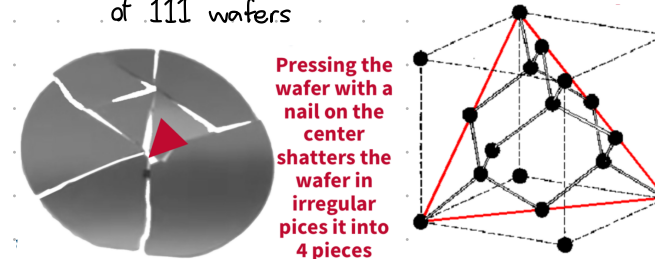
- The surface aligns w/ Si lattice
 - (atoms form an equilateral triangle)
- For applications req. high mobility of electrons; e.g. RF devices
- Unique electrical prop. due to its symmetry



How <1, 1, 1> break:

Cleavage planes are NOT parallel to wafer structure but angled through the wafer; pyramide sides w/in.

- break into many unpredictable fragments when stressed as the crack propagates along multiple cleavage planes
- a challenge, but proper dicing allows exploit. of 111 wafers

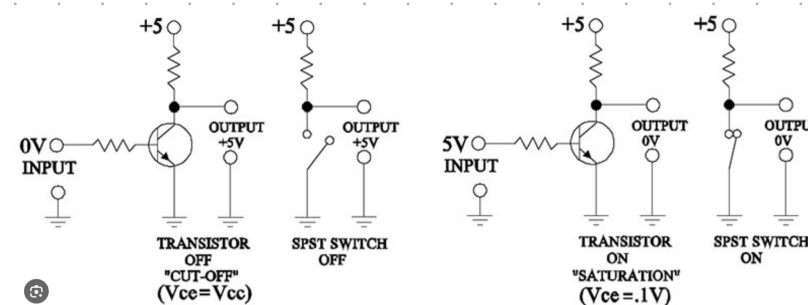


Introduction to Transistors:

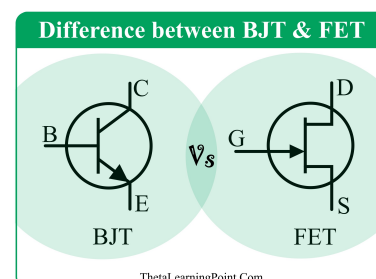
transistors act as a switch, an amplifier, or a signal modulator; it manages current flow & manipulate signals

Importance: replaced bulky vacuum tubes; enabled miniaturization, improve efficiency, & enhance performance

- Acts as switches that control current flow based on a voltage applied to their control terminal (base)
- Binary input & output:
 - high voltage (often 5V) = logical 1
 - low voltage (often ground 0V) = logical 0



- No voltage to base $\Rightarrow$ "off", open circuit, blocking current flow
- Voltage to base $\Rightarrow$ "On" (saturation mode), current flows btwn. collector & emitter



BJT: small I regulates a large I .

FET: small V regulates a large I .

Basic Principles of Transistors

Energy Bands & Band Gaps:

available energy states form bands due to the proximity of energy levels

Valence Band:

contains electrons that are tightly bonded to atoms; not free to move & contribute to stability.

Conduction Band:

electrons have higher energy & are able to move freely within the mat.

$V.B. \Rightarrow e^- \Rightarrow C.B.$, becomes mobile & can participate electrical conduction

Band Gap:

space btwn $V.B.$ & $C.B.$; energy range where no electrons can exist; size varies by mat. & influences its prop.

Types of Transistors

Bipolar Junction Transistors (BJTs).

Three-layer semiconductor devices w/ PNP or NPN config.
→ operate by controlling flow of current through base region, influencing the collector-emitter current
→ commonly used for amplification & switch applications

Field-Effect Transistors (FETs).

Voltage-controlled devices that regulate current flow based on an applied $\vec{B}$; 3 types:

Metal-Oxide-Semiconductor FETs (MOSFETs):

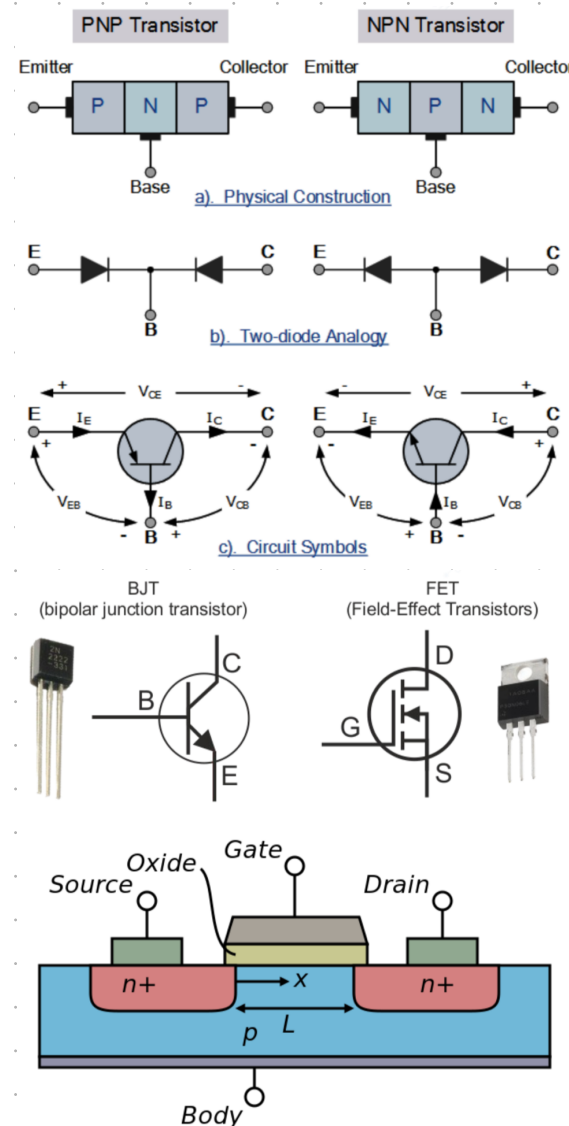
widely used in digital circuits; can be enhanced-mode or depletion-mode

Junction FETs (JFETs):

utilize a PN junction to control current; commonly used in low-noise amplifiers

Insulated-Gate Bipolar Transistors (IGBTs):

combines features of BJTs & MOSFETs; used in power electronics.

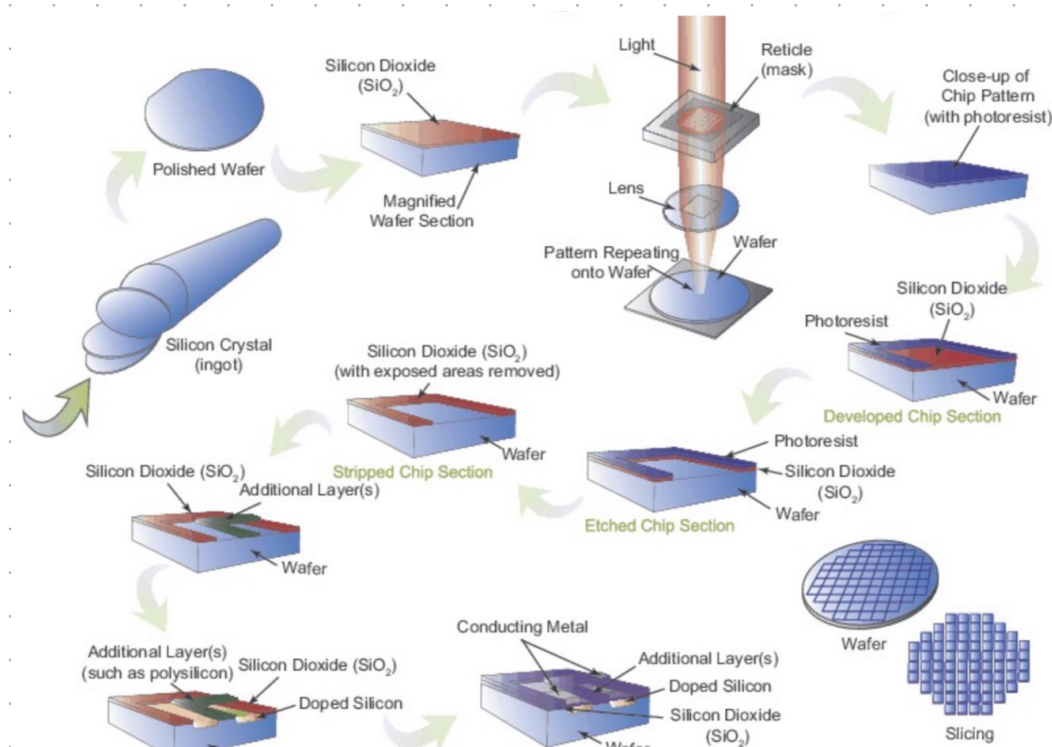


Fabrication of Transistors & Integrated Circuits:

Wafer Mfg. $\Rightarrow$ Oxidation $\Rightarrow$ Lithography $\Rightarrow$ Etching

$\Rightarrow$ Ion Implementation & Deposition $\Rightarrow$ Metallization

$\Rightarrow$ Testing & Packaging



Cleanroom Requirements: particle free

Controls:

Temperature & Humidity

prevent warping of wafers & ensure consistent process behavior.

Air Quality

stringent filtration systems to remove dust particles, airborne molecules, & even bacteria

Special Suits

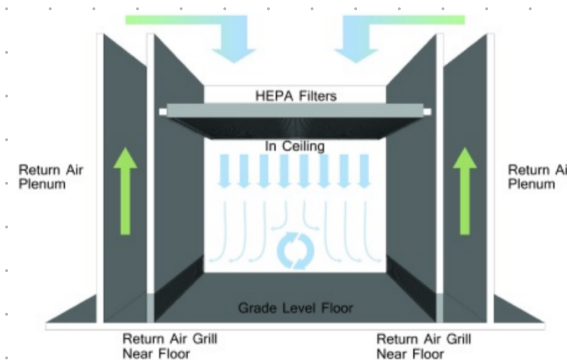
AKA bunny suits made of lint-free materials to prevent shedding of hair, skin flakes, & clothing fibers.

Air Filtration

Multistage filtration systems including High-Efficiency Particulate Air (HEPA) filters, which removes particles as small as 0.1 micrometers from air.

Regular Cleaning & Monitoring

continuous cleaning protocols ensure dust & contaminant removal



Oxidation: Silicon Dioxide & Its Properties

Excellent Insulator

high bandgap $\rightarrow$ effective electrical insulator helps prevent unwanted current flow.

Chemical Stability:

resists corrosion & degradation from various chemicals & processes

Good Thermal Stability:

withstand high temp. in some fabrication steps

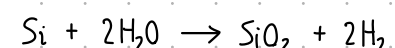
Relatively Good Growth Uniformity:

across the wafer, ensuring consistent electrical properties

Growing the Oxide Layer:

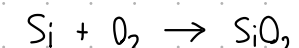
Wet Oxidation:

traditional method utilizes water vapor @ high temp. (900 ~ 1100°C) to oxidize exposed silicon:



Dry Oxidation:

uses molecular oxygen (O_2) at lower temps. (700 ~ 900°C) to achieve oxidation



Silicon Dioxide: Roles in Transistors

Gate Oxide

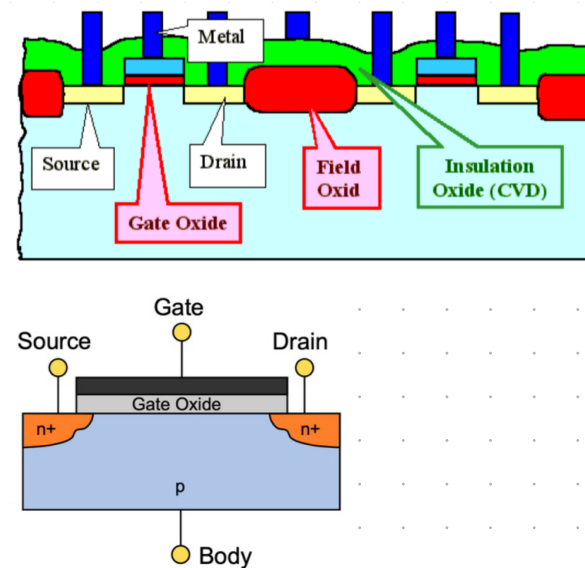
a thin layer of SiO_2 grown on the silicon substrate to act as the gate insulator in a transistor; isolates gate electrode from channel region, controlling current.

Field Oxide

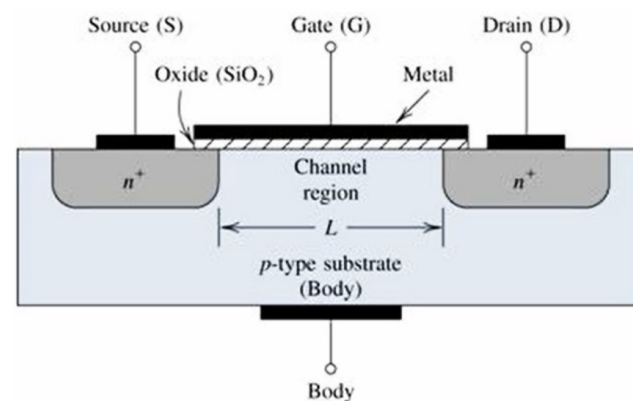
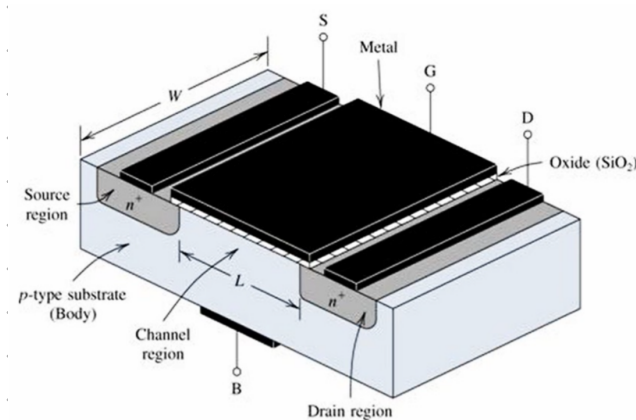
thicker layers of SiO_2 used to isolate diff. transistors & other circuit elements on wafer, preventing electrical interaction & ensuring proper circuit operation.

Passivation Layer

thin layer of SiO_2 deposited to protect underlying silicon surface from contaminants & improve device reliability.



NPN Field Effect Transistors:

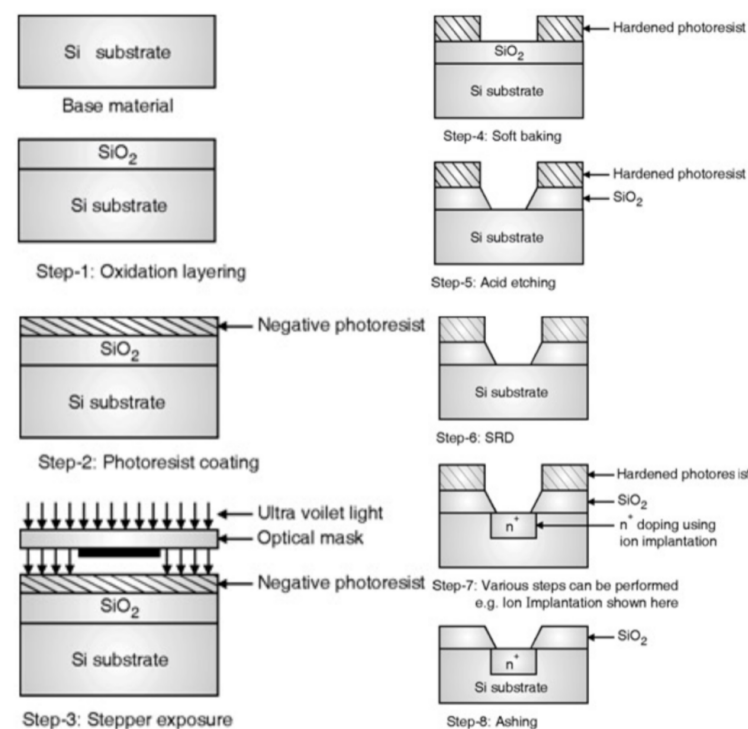
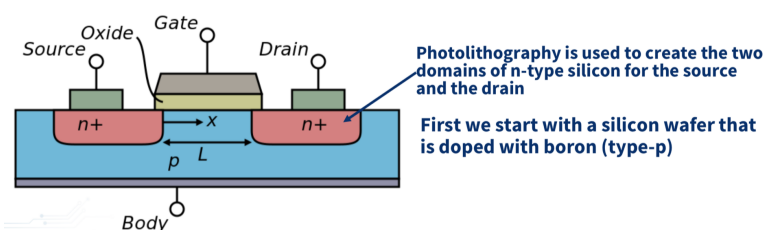


SiO_2 layer prevents gate electrode from shortcircuiting source & drain.

V_{gate} modulates the width of the channel between the source & the drain, changing I_{SD} .

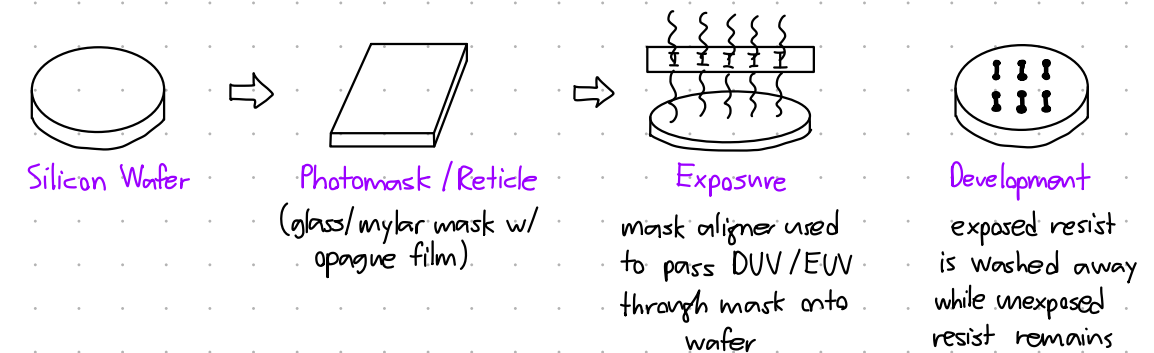
How To Fabricate a NPN Transistors:

- Start w/ a silicon wafer type-p (doped w/ Boron; has 3 valence e^-)
- Create two type-n domains one for the source, one for the drain; done by creating two openings on a layer of SiO_2 via photolithography SiO_2 layer AKA implantation layer
- Photolithography used again to achieve metal deposition of source/drain/gate.



Photolithography

enables the transfer of intricate circuit designs onto silicon wafers w/ high precision; utilizes light-sensitive materials & a series of steps to create a patterned resist layer that guides the subsequent processes like oxid. & etch.



Photoresist Application

- apply a thin layer of **photoresist**, a light-sensitive polymer onto wafer
- different types of photoresist have varying sensitivities to specific wavelengths of light.
 - positive resists become more soluble upon exposure
 - negative resists become less soluble upon exposure
 - choice depends on desired pattern transfer & subsequent processing steps

Photoresist Application Technique

Spin Coating

most common method; wafer spun at high speeds while the photoresist is dispensed onto the center. Centrifugal forces distribute the resist uniformly, creating a thin film w/ a consistent thickness across the wafer surface.

Spray Coating